

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/711,445	CHEN ET AL.	
Examiner	Art Unit	
David Goodwin	2818	

	SEARCHED						
Class	Subclass	Date	Examiner				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
438/164, 165, 197, 211, 257, 663, 264, 595, 594, 682, 695, 755, 770, 780	10/20/2005	DJG		
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